



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent application:)
Hisato SHINOHARA et al.)
Application Serial No. 08/169,127) Art Unit: 1762
Filed: December 20, 1993) Examiner: Marianne L. Padgett
For: METHOD AND SYSTEM OF)
LASER PROCESSING)

SUPPLEMENTAL AMENDMENT

Mail Stop **AMENDMENT**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed May 19, 2004, to the Examiner interview conducted April 19, 2005, and to the Advisory Action mailed May 25, 2005, and further to the Amendment filed April 28, 2005, please consider the following Supplemental Amendments and remarks in connection with this instant application.